

Diffraction imaging

- Originated by David Sayre
- Developed @ NSLS by Stony Brook group (Miao thesis)
- Current work @ ALS, APS, Spring8, BESSYII
- Basic idea: Image non-crystalline object by recording diffraction pattern
- Recover lost phase information by "oversampling" (pattern continuous, not limited to Bragg peaks)
- Iterative algorithm used in reconstruction

The role of coherent X-ray diffraction

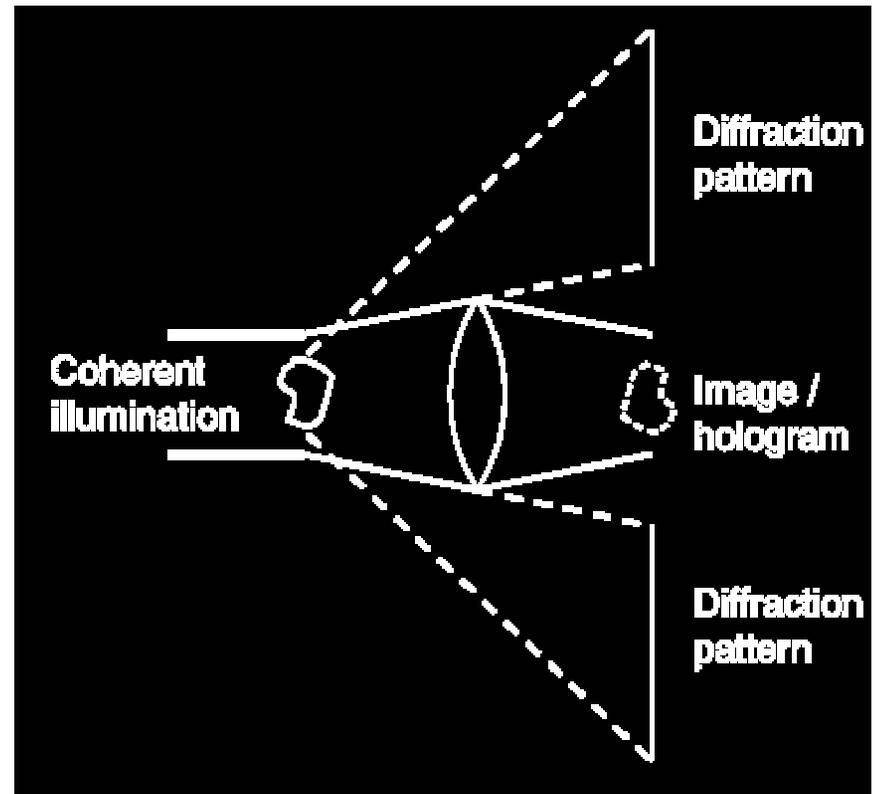
- A technique for **3D imaging** of 0.5 - 20 μm isolated objects
- Too thick for EM (0.5 μm is practical upper limit)
- Too thick for tomographic soft X-ray microscopy (depth of focus $< 1 \mu\text{m}$ at 10 nm resolution for soft X-rays even if lenses become available)

Goals

- 10 nm resolution (3D) in 1 - 10 μm size biological specimens
(small frozen hydrated cell, organelle; see macromolecular aggregates)
Limitation: radiation damage!
- < 4 nm resolution in less sensitive nanostructures
(Inclusions, porosity, clusters, composite nanostructures, aerosols...)
eg: molecular sieves, catalysts, crack propagation

Imaging beyond the lens limit?

- Working from diffraction patterns:
 - No optics-imposed resolution limits!
- Working from images:
 - The lens phases all the Fourier plane information.
 - The lens limits resolution.



- Holography: mix in a reference phase

Where we really want to be

- Collect a high resolution 3D data set in an hour or two
- Reconstruct reliably in a comparable amount of time

Challenges:

1/ getting sufficient coherent photons

- Here is where NSLS II comes in!

2/Choice of energy

- Reconstruction of real objects is easier.
- Electron density becomes more nearly real as energy increases.
- Exposure time scales as E^4 . (Coherent flux for fixed brightness scales as E^{-2} , and cross section scales as E^{-2})
- Best compromise specimen dependent 0.5 - 4 KeV

3/ recording the pattern

- Eliminate higher orders: aperiodic undulator?
- Shielding detector from all but diffracted signal
- Aligning specimen with small beam-spot,
 - Keeping it aligned as specimen is rotated
- Minimizing missing data
(beam stop, large rotation angles, etc.)
- Dynamic range of detector

Challenges

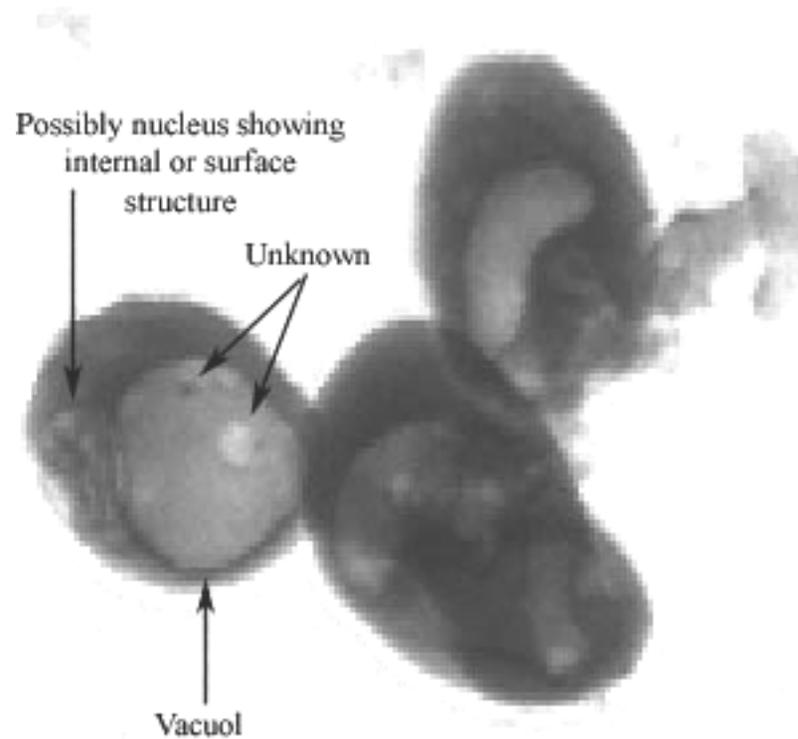
4/reconstruction

5/ damage

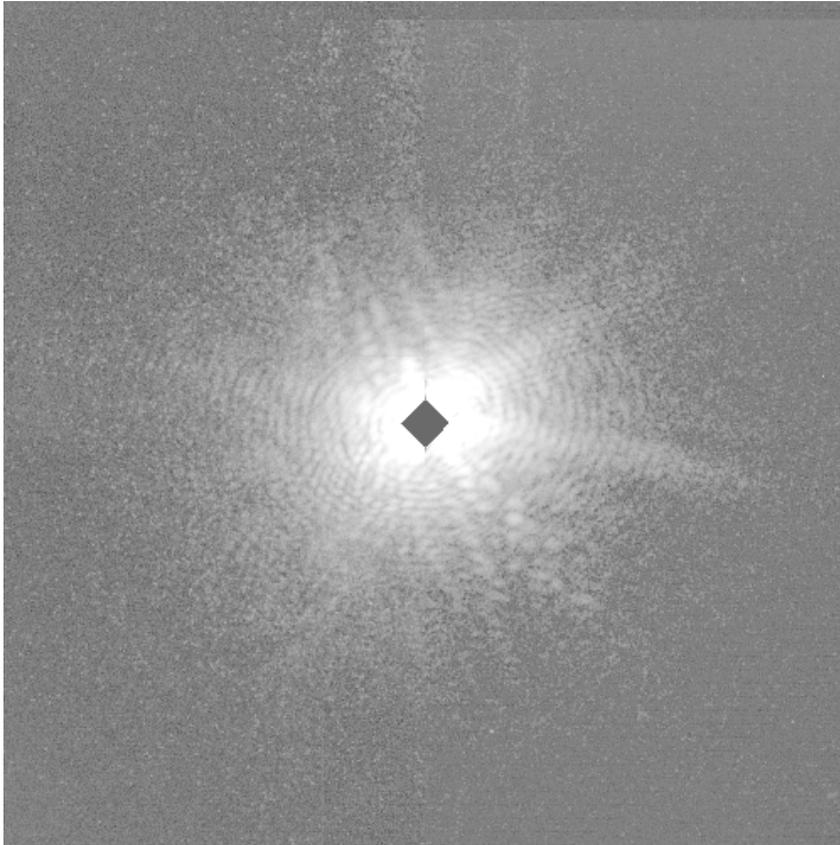
The ultimate limitation for radiation-sensitive materials only

Low temperature helps, but not in chemical mapping

Freeze-dried yeast cells



Diffraction pattern from freeze-dried yeast cell



- $\ln \sqrt{I}$
- Combination of multiple exposures
- Edge of figure: 45 nm
pattern extends half way